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SUBSTITUTE FORM PTO-1449
U.S. DEPARTMENT OF COMMERCE
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ATTY. DOCKET NO. 9325-49 (149169)

SERIAL NO. 09/826,236

INFORMATION DISCLOSURE CITATION

Scott W. Huffer, et al.

April 4, 2001

APPLICANT:

GROUP 1773

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
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	AE	EP 0 870 695 A1	10/14/98	EPO	1865D	65/14		

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1	AR Silicone Acrylate System, Ebbrecht T. et al., EuroCoat, 9/1992						
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